



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov



Bio Data Sheet

CONFIRMATION NO. 8647

SERIAL NUMBER 10/656,130	FILING DATE 09/08/2003 RULE ✓	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 00839.000419.1
-----------------------------	---	--------------	------------------------	---------------------------------------

APPLICANTS

Makoto Higashikawa, Kyotanabe-shi, JAPAN;

Masafumi Sano, Soura-gun, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/261,499 03/03/1999 PAT 6,645,573

** FOREIGN APPLICATIONS *****

JAPAN 050321/HEI.10 03/03/1998

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/28/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>M. M. Chandra</i> Initials <i>MS</i>				

ADDRESS

5514
FITZPATRICK CELLA HARPER & SCINTO
30 ROCKEFELLER PLAZA
NEW YORK, NY
10112

TITLE

Process for forming a microcrystalline silicon series thin film and apparatus suitable for practicing said process

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	---